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Bib Data Sheet

CONFIRMATION NO. 8919

SERIAL NUMBER 10/686,634	FILING DATE 10/17/2003 RULE	CLASS 257	GROUP ART UNIT 2826	ATTORNEY DOCKET NO. 104741.01
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APPLICANTS

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** CONTINUING DATA *****

This application is a CON of 09/423,969 11/17/1999 ABN
 which is a 371 of PCT/JP99/01327 03/17/1999

verified-sm

** FOREIGN APPLICATIONS *****

JAPAN 10-67508 03/17/1998

JAPAN 11-32123 02/10/1999

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 24	TOTAL CLAIMS 34	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	<i>[Initials]</i> Initials			

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TITLE

Method of forming thin film patterning substrate including formation of banks

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)